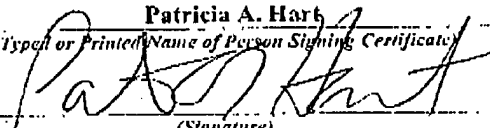


<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>			Docket No. <b>YKI-0084</b>
Applicant(s): <b>Takashi Hagino et al.</b>			
Serial No. <b>10/080,424</b>	Filing Date <b>02/22/2002</b>	Examiner <b>William D. Coleman</b>	Group Art Unit <b>2823</b>
Invention: <b>METHOD FOR MANUFACTURING POLYCRYSTALLINE SEMICONDUCTOR LAYERS AND THIN-FILM TRANSISTORS, AND LASER ANNEALING APPARATUS</b>			
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I hereby certify that this _____ <u>Petition for Extension of Time (1 pg); Amendment (6 pgs)</u> _____ (Identify type of correspondence)			
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